



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: ERIC J. BERGMAN

APPLICATION No.: 10/631,376

FILED: JULY 30, 2003

FOR: **METHODS OF THINNING A SILICON WAFER  
USING HF AND OZONE**

EXAMINER: Z. EL ARINI

ART UNIT: 1746

CONF. No: 2135

**AMENDMENT**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed 10/03/2005, please amend the  
Application as follows:

Amendments to the claims are reflected in the listing of claims which begins  
on page 2 of this paper.

Remarks begin on page 7 of this paper.

[Continued on Next Page.]

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Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

December 23, 2005  
Date of Deposit

Debbie Gilbert  
Debbie Gilbert